

Docket No. 2000-0086-1
USSN 09/716,041

Date of Deposit: February 25, 2003	CERTIFICATE OF MAILING BY "FIRST CLASS MAIL"
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: J. Nguyen
William N. Partlo, et al.)	
Serial No.: 09/716,041)	Group Art Unit: 2815
Filed: November 17, 2000)	
For: HIGH POWER GAS DISCHARGE LASER)	
WITH HELIUM PURGED LINE)	
NARROWING UNIT)	

BOX AF
Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO FINAL OFFICE ACTION

Sir:

This letter is in response to Office Action mailed November 26, 2002.

REMARKS

The Examiner has rejected Applicants' claims based on an abandoned patent application ('374 Osamu) which was discredited by the authors' of the application. Applicants' requests reconsideration. The authors stated in a subsequent application that the technique referred to in the abandoned application would not work and "must be avoided". Under these circumstances the abandoned application is not a proper reference against Applicants' invention.